

**Electronic Filing System (EFS) Data  
Electronic Patent Application Submission  
USPTO Use Only**

EFS ID: 13549  
Application ID: 09683533  
Title of Invention: SYSTEMS AND METHODS FOR  
THERMAL ISOLATION OF A  
SILICON STRUCTURE  
First Named Inventor: Joel KUBBY  
Domestic/Foreign Application: Domestic Application  
Filing Date: null  
Effective Receipt Date: 2002-01-16   
Submission Type: Utility Patent Filing  
Filing Type: new-utility  
Confirmation Number: 0  
Attorney Docket Number: 111014  
Digital Certificate Holder: cn=Thomas J. Pardini, ou=Registered Attorneys, ou=Patent and  
Trademark Office, ou=Department of Commerce, o=U.S.  
Government, c=US  
Certificate Message Digest: xBMdlq8NLJIlwCSVDVxwtg==  
Total Fees Authorized: \$780.0

Payment Category: DA - Deposit Account  
Deposit Account Number: 240037  
Deposit Account Name: Thomas J. Pardini

# APPLICATION DATA SHEET

Electronic Version 0.0.11

Stylesheet Version: 1.0

Attorney Docket Number: 111014

Publication Filing Type: new-utility

Application Type: utility

Title of Invention: SYSTEMS AND METHODS FOR THERMAL ISOLATION OF A SILICON  
STRUCTURE

Suggested Representative Figure: 2

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